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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/771,547	01/30/2001	Toshiyuki Sato	D-1059	8819
7590 12/16/2004			EXAMINER	
HAUPTMAN KANESAKA BERNER PATNET AGENTS, LLP			AGGARWAL, YOGESH K	
1700 Diagonal Road Suite 310 Alexandria, VA 22314			ART UNIT	PAPER NUMBER
			2615	

DATE MAILED: 12/16/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

DT

,		Application No.	Applicant(s)				
Office Action Summary		09/771,547	SATO ET AL.				
		Examiner	Art Unit				
		Yogesh K Aggarwal	2615				
	The MAILING DATE of this communication ap	pears on the cover sheet with the c	correspondence address				
Period for Reply							
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).							
Status							
1)⊠	Responsive to communication(s) filed on 16.	August 2004.					
		is action is non-final.					
3)	Since this application is in condition for allows	ance except for formal matters, pro	osecution as to the merits is				
	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.						
Dispositi	ion of Claims						
4)⊠ Claim(s) <u>1-7</u> is/are pending in the application.							
4a) Of the above claim(s) is/are withdrawn from consideration.							
5) Claim(s) is/are allowed.							
·	6)⊠ Claim(s) <u>1-7</u> is/are rejected.						
7)	Claim(s) is/are objected to.						
8)□	Claim(s) are subject to restriction and/	or election requirement.					
Applicati	ion Papers						
9) The specification is objected to by the Examiner.							
10)⊠ The drawing(s) filed on <u>30 January 2001</u> is/are: a)⊠ accepted or b)□ objected to by the Examiner.							
/	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).							
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.							
Priority under 35 U.S.C. § 119							
12)⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).							
a)⊠ All b)□ Some * c)□ None of:							
,.	1.⊠ Certified copies of the priority documents have been received.						
2. Certified copies of the priority documents have been received in Application No							
3. Copies of the certified copies of the priority documents have been received in this National Stage							
application from the International Bureau (PCT Rule 17.2(a)).							
* See the attached detailed Office action for a list of the certified copies not received.							
Attachment(s)							
	te of References Cited (PTO-892)	4) Interview Summary Paper No(s)/Mail D					
3) Inform	ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08 er No(s)/Mail Date		ate Patent Application (PTO-152)				

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## Response to Arguments

1. Applicant's arguments with respect to claims 1-7 have been considered but are moot in view of the new ground(s) of rejection.

### Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1, 2 and 4-7 are rejected under 35 U.S.C. 103(a) as being unpatentable over Applicant's admitted prior art in view of Huang et al. (US Patent # 5,917,210).

[Claims 1 and 2]

Applicant's admitted prior art teaches a radiation detector comprising an active matrix board (Paragraphs 1-11, figure 3, element 10) including gate lines (4) and data lines (5) arranged in a two-dimensional lattice form, a plurality of high-speed switching elements (3) provided at respective lattice points and connected to the gate lines and the data lines, each having a source electrode, pixel electrodes connected to the source electrodes of the high-speed switching elements, and charge storage capacitances (2), each being disposed between the pixel electrode and a ground electrode (Paragraph 3) and a converting layer (1) formed on the pixel electrodes to generate a pair of electron-hole by absorbing one of light and radiation (Paragraph 8) except that each high-speed switching elements are formed of polycrystalline silicon thin film

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transistors and converting layer being formed of a material (one of CdTe and CdZnTe) having a heat resistant temperature more than about 250 degree C.

Applicant's admitted prior art does not explicitly teach that each high-speed switching elements are formed of polycrystalline silicon thin film transistors and converting layer being formed of a material (one of CdTe and CdZnTe) having a heat resistant temperature more than about 250 degree C. However Huang et al. teach that said high-speed switching elements are formed of polycrystalline silicon thin film transistors (col. 1 lines 16-23). As for the newly added limitation of said converting layer being formed of a material (one of CdTe and CdZnTe) having a heat resistant temperature more than about 250 degree C. Huang discloses that the converting layer is formed of either CdTe/CdSe (col. 8 lines 10-12, i.e. one of Cadmium Telluride or Cadmium Selenide, both belong to the oxygen group in the periodic table). It is known in the art that CdTe have a melting point of 800 degrees C. Therefore a substance like CdTe inherently has a heat resistant temperature of more than 250 degree C. Therefore Huang inherently disclose a converting layer having a temperature well above 250 degree C.

Therefore taking the combined teachings of Applicant's admitted prior art in view of Huang it would have been obvious to one skilled in the art at the time of the invention to have been motivated to have used a high speed switching element made of polycrystalline silicon thin film transistors and a converting layer being formed of a material (one of CdTe and CdZnTe) having a heat resistant temperature more than about 250 degree C. The benefit of doing so is that a novel TFT structure is provided characterized by no parasitic capacitance on either the drain or the source electrodes as taught in Huang (col. 3 lines 35-38).

### [Claim 4]

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Applicant's admitted prior art teaches wherein said active matrix board (figure 2: 10) further includes a base plate (figure 2: 11) having high heat resistance and insulating property, an insulating film (figure 2: 2b) disposed on the base plate and sandwiched by the gate lines (figure 2: 4) and data lines (figure 2: 5), an insulating protecting layer (figure 2: 12) disposed on the insulating film above the switching element, and a common electrode (figure 2: 1b) disposed on the converting layer.

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[Claim 6]

Huang discloses each switching element being formed of poly-silicon TFT (col. 1 lines 16-22). ). It is known in the art that Poly-silicon has a melting point of 1400 degrees C which is well above 300 degree C. Therefore poly-silicon inherently has a heat resistant temperature of more than 300 degree C. Therefore Huang inherently disclose a switching element having a temperature above 300 degree C.

[Claim 7]

See Claims 1 and 2.

4. Claim 5 is rejected under 35 U.S.C. 103(a) as being unpatentable over Applicants' admitted prior art in view of Huang et al. (US Patent # 5,917,210) in further view of Yamazaki (US PG-PUB # 2002/0163035).

[Claim 5]

Applicant's admitted prior art teaches a radiation detector comprising gate driving circuit (figure 3: 6) to be connected to the gate lines (figure 3: 4), a signal driving circuit (figure 3: 7) to be connected to the data lines (figure 3: 5). Applicant's admitted prior art fails to teach a signal process circuit formed on the active matrix board for connecting the gate lines and data lines to

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the gate driving circuit and the signal driving circuit. However Yamazaki teaches a signal processing circuits (figure 8: 702 and 703) formed on the active matrix board substrate (figure 8: 100) and connected to the pixel section 701 through gate wiring 704 and source wiring 158 (Paragraph 135). Therefore taking the combined teachings of Applicant's admitted prior art in view of Huang it would have been obvious to one skilled in the art at the time of the invention to have been motivated to have a signal process circuit formed on the active matrix board for connecting the gate lines and data lines to the gate driving circuit and the signal driving circuit as taught in Yamazaki in order to improve the operation performance and the reliability of a semiconductor device by properly using the TFT structures on the same substrate as taught in Yamazaki (Paragraph 19).

#### Conclusion

- 5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.
- i. Harmand et al. (US Patent # 6,107,113) discloses melting point of CdTe (800 degree col. 3 lines 7-8).
- ii. Sukegawa (JP Patent # 05275301A) discloses melting point of poly-silicon to be about 1400 degree C).
- 6. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO

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MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Yogesh K Aggarwal whose telephone number is (703) 305-0346. The examiner can normally be reached on M-F 9:00AM-5:30PM.

- 7. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Andrew Christensen can be reached on (703) 308-9644. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.
- 8. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

YKA December 10, 2004 TUAN HO
PRIMARY EXAMINER